

Notice of References Cited	Application/Control No. 10/562,884		Applicant(s)/Patent Under Reexamination NIEUWLAND ET AL.	
	Examiner HANA A. SANEI		Art Unit 2889	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0029949	02-2005	Cillessen et al.	313/625
*	B	US-5,795,837	08-1998	Wei et al.	501/87
*	C	US-4,880,707	11-1989	Kohno et al.	428/565
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Bohn et al., Structural materials: metal-silicon-boron, Elsevier, Journal of Alloys and Compounds 347 (2002), pg. 94-100
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.